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May 2001



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Metrology Challenges for the 21st Century

*Dean Beutel
Caterpillar, Inc.*

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Outline

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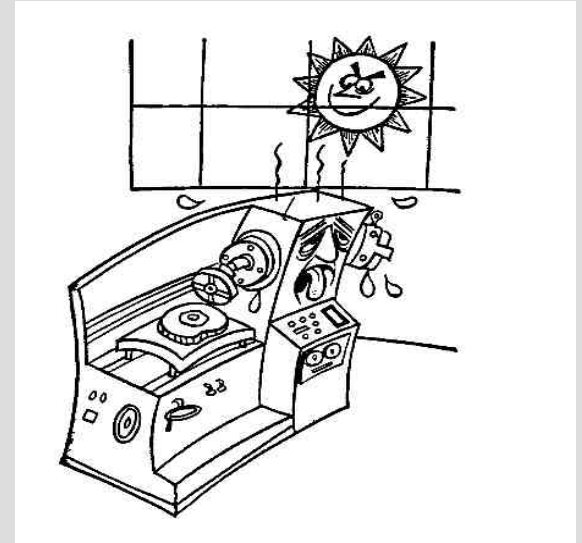
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- ◆ Metrology Challenges for the 21st Century
 - ▶ Temperature Variation
 - ▶ Open Architecture Controls
 - ▶ Throughput vs. Accuracy
 - ▶ Large Scale Metrology
- ◆ Future Vision
- ◆ Questions/Answers



Temperature variation is the largest source of non-repeatability and inaccuracy

- ◆ **Need** - Measure parts immediately after they are machined to control mfg. process
- ◆ **Current Status**
 - ▶ Use of temp. controlled labs & enclosures
 - ▶ Compensate for the part temperature variation with a single sensor
 - ▶ Ignore temperature variation in the part
 - ▶ Adopt thermally optimized factory concept
- ◆ **Challenge** - A real time temperature compensation system transparent to the operator



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Open Architecture

- ◆ **Need** - To have a common interface in controls
- ◆ **Current Status**
 - ▶ No commonality
 - ▶ Proprietary (rigid) interfaces
 - ▶ OEM's have started opening their controls
- ◆ **Challenge** - Integrate any software with any hardware and to have seem-less integration with a desired CAD package

Throughput with Accuracy

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Throughput with Accuracy

- ◆ Need - faster real-time feedback for process control
- ◆ Current status
 - ▶ Post-process measurements
 - ▶ Time lag
- ◆ Challenge to OEM's
 - ▶ Keep up with the speeds of machine tools without losing accuracy
 - ▶ Move metrology equipment from lab to shop-floor

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Large Scale Metrology (Measurements on the scale of one meter or larger)

- ◆ **Need** - Measure large parts accurately and cost effectively
- ◆ **Current Status**
 - ▶ Large metrology equipment (CMM's) are expensive
 - ▶ Low throughput
 - ▶ Laser trackers and articulated arms do not meet accuracy and throughput requirements
- ◆ **Challenge** - Come up with a measurement system that can meet the requirements

Future Vision

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- ◆ More advanced machine designs
- ◆ New sensors that expand measurement capability
- ◆ Software enhancements to increase the usefulness
- ◆ Temperature variation will play a predominant role
- ◆ Accuracy improvements



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